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Bib Data Sheet

CONFIRMATION NO. 1476

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|-----------------------------|---------------------------------------|--------------|------------------------|--------------------------------|
| SERIAL NUMBER 10/616,863 | FILING DATE 07/10/2003 RULE | CLASS 430 | GROUP ART UNIT 1756 | ATTORNEY DOCKET NO. 7151 |
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APPLICANTS

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** CONTINUING DATA *****

SKM NONE

** FOREIGN APPLICATIONS *****

SKM NONE

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 10/09/2003

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|--|-----------------------------|------------------------|-----------------------|----------------------------|
| Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no | STATE OR COUNTRY WI | SHEETS DRAWING 4 | TOTAL CLAIMS 23 | INDEPENDENT CLAIMS 4 |
| 35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance | | | | |
| Verified and Acknowledged | Examiner's Signature SKM | Initials SKM | | |

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TITLE

Defect inspection of extreme ultraviolet lithography masks and the like

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